



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1763/11
[10191/1690] #6

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TC 1700

Applicants : BECKER et al.

Serial No. : 09/762,985

Filed : May 8, 2001

For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE
USING AN INDUCTIVELY COUPLED PLASMA

Examiner : L. Alejandro

Art Unit : 1763

Commissioner for Patents
Washington, D.C. 20231

we hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
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Date: 1/16/03

Reg. 41,172

Signature

D. Magistre
DERVIS MAGISTRE
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ELECTION TRANSMITTAL

SIR:

Please find an Election With Traverse transmitted herewith for filing in the
above-identified patent application.

Applicants hereby request a three-month extension of time. The extended
~~period for response expires on January 25, 2003. Please charge the \$930.00 extension fee and~~
any other fee that may be required to Deposit Account No. 11-0600. A duplicate of this
Transmittal is enclosed.

Respectfully submitted,

KENYON & KENYON

By: *D. Magistre*

Dated: 1/16/03

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